

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/780,761	<b>Applicant(s)/Patent under Reexamination</b> OKUDA, TATSUO
	<b>Examiner</b> YOGESH K. AGGARWAL	<b>Art Unit</b> 2622

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner